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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/067,265	02/07/2002	Jun Dong Kim	P67585US0	6688
136	7590	11/24/2003	EXAMINER	
JACOBSON HOLMAN PLLC 400 SEVENTH STREET N.W. SUITE 600 WASHINGTON, DC 20004			SARKAR, ASOK K	
			ART UNIT	PAPER NUMBER
			2829	

DATE MAILED: 11/24/2003

Please find below and/or attached an Office communication concerning this application or proceeding.



Continuation of 2. NOTE: The new limitation of dry etching process using plasma dry etching equipment raise new issue that would require further consideration and/or search..

Continuation of 5. does NOT place the application in condition for allowance because: The Applicant's arguments are not persuasive since Kashihara teaches that the etching process can be either dry or wet and Wolf and Tauber teach the advantages of dry etching with plasma of etchant gases wherein plasma is created by microwave.